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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Takaaki NAGAI

Serial No.: 09/837,734

Filed: April 17, 2001

Title: **NON-VOLATILE SEMICONDUCTOR STORAGE APPARATUS AND MANUFACTURING METHOD THEREOF**

Examiner: Douglas W. Owens

Group Art Unit: 2811

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

A M E N D M E N T

SIR :

In response to the Office Action dated August 23, 2004, the period for responding thereto expiring after November 23, 2004, please amend the subject application as follows: